	Application No.	Applicant(s)	
•	10/743,904	KOMATSU ET AL.	$(0 \sim$
Notice of Allowability	Examiner	Art Unit	(
	Leith A. Al-Nazer	2821	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT I of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in 5) or other appropriate commu RIGHTS. This application is s	this application. If not include inication will be mailed in due c	d ourse. THIS
1. This communication is responsive to 20 June 2005.			
2. The allowed claim(s) is/are <u>1-8</u> .			
3. \boxtimes The drawings filed on <u>13 April 2004</u> are accepted by the l	Examiner.		
4. Acknowledgment is made of a claim for foreign priority to a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 1. Certified copies of the certified copies of the priority documents have 1. Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be subtracted in the subtraction of the priority of the priority documents have subtracted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	ve been received. ve been received in Application occuments have been received. " of this communication to file MENT of this application. mitted. Note the attached EXA ves reason(s) why the oath or just be submitted. rson's Patent Drawing Review	n No I in this national stage application a reply complying with the requirement of the stage application is deficient. (PTO-948) attached	uirements
 (b) including changes required by the attached Examiner Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in 	1.84(c)) should be written on th	e drawings in the front (not the l	oack) of
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT 			ote the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☑ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Su	ormal Patent Application (PTO-	-152)
3. Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date	(08), 7. ☐ Examiner's <i>i</i>	Mail Date Amendment/Comment	
4. Examiner's Comment Regarding Requirement for Deposit		Statement of Reasons for Allow	/ance
of Biological Material	9.	Shik-Ulao Chen Shih-Chao Chen Primary Examiner	

Application/Control Number: 10/743,904 Page 2

Art Unit: 2821

DETAILED ACTION

Allowable Subject Matter

1. Claims 1-8 are allowed.

2. The following is an examiner's statement of reasons for allowance:

The prior art of record fails to teach or suggest one or more of the limitations found in independent claim 1. Specifically, with respect to claim 1, the prior art of record (Izadian '936 and Pakray et al. '811) fails to teach or suggest the first radiation element and the grounding conductor being provided on the same surface of the dielectric substrate. Therefore, independent claim 1, as well as all dependent claims, is allowable over the prior art of record.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Communication Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Leith A. Al-Nazer whose telephone number is 571-272-1938. The examiner can normally be reached on Monday-Friday, 7:30-4:00.

Application/Control Number: 10/743,904 Page 3

Art Unit: 2821

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Don Wong can be reached on 571-272-1834. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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